IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Ronald Weimer et al.

Serial No.: 09/296,835

Group Art Unit: 2813

Filed: April 22, 1999

Examiner: Not Yet Assigned

For: FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET RAPID THERMAL OXIDATION PROCESS

Assistant Commissioner for Patents Washington, D.C. 20231

POWER OF ATTORNEY BY ASSIGNEE AND CERTIFICATE BY ASSIGNEE UNDER 37 CFR § 3.73(b)

Micron Technology, Inc., Assignee of the entire right, title and interest in the above-identified application by virtue of the Assignment, a copy of which is attached hereto, hereby appoints the attorneys and agents of the firm of Dickstein, Shapiro, Morin & Oshinsky, listed as follows: Gary M. Hoffman, 26,411; Thomas J. D'Amico, 28,371; Donald A. Gregory, 28,954; James W. Brady Jr., 32,115; Jon D. Grossman, 32,699; Mark J. Thronson, 33,082; Jeremy A. Cubert, 40,399; Laurence E. Fisher, 37,131; Brian A. Lemm, 43,748; Gianni Minutoli, 41,198; Edwin Oh, P-45,319; Eric Oliver, 35,307; William E. Powell III, 39,803; Paul L. Ratcliffe, 45,290; Mark E. Strickland, 45,138 and Salvatore P. Tamburo, 45,153, and also attorneys of Micron Technology, Inc. as its

substitution to prosecute this appl on and to transact all attorneys with full pow business in the Patent and Trademark Office in connection therewith.

The Assignee certifies that the above-identified assignment has been reviewed and to the best of the Assignee's knowledge and belief, title is in the assignee.

Please direct all correspondence regarding this application to the following:

Thomas J. D'Amico Dickstein Shapiro Morin & Oshinsky LLP 2101 L Street NW

Telephone: (202) 785-9700

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(202) 887-0689

MICRON TECHNOLOGY, INC.

Michael L. Lynch

Chief Patent Counsel Registration No. 30,871

Dated:





For valuable consideration, We, Ronald A. Weimer of 1696 E. Victory Road, Boise, Idaho 83706, Scott J. DeBoer of 259 E. Twin Willow, Boise, Idaho 83706, Dan Gealy of 4300 Junayo Ln, Kuna, Idaho 83634 and Husam N. Al-Shareef of 2856 W. Cherry Lane, Boise, Idaho 83704 hereby assign to Micron Technology, Inc., a Delaware corporation having a place of business at 8000 S. Federal Way, Boise, Idaho 83706-9632, and its successors and assigns (collectively hereinafter called "the Assignee"), the entire right, title and interest throughout the world in the inventions and improvements which are subject of an application for United States Patent signed by us, entitled

FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET RAPID THERMAL OXIDATION PROCESS

filed on April 22, 1999 and assigned U.S. Serial Number 09/296, 835, and we authorize and request the attorneys appointed in said application to hereafter complete this assignment by inserting above the filing date and serial number of said application when known; this assignment including said application, any and all United States and foreign patents, utility models, and design registrations granted for any of said inventions or improvements, and the right to claim priority based on the filing date of said application under the International Convention for the Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all other treaties of like purposes; and we authorize the Assignee to apply in all countries in our name or in its own name for patents, utility models, and design registrations and like rights of exclusion and for inventors' certificates for said inventions and improvements; and we agree for ourselves and our respective heirs, legal representatives and assigns, without further compensation to perform such lawful acts and to sign such further applications, assignments, Preliminary Statements and other lawful documents as the Assignee may reasonably request to effectuate fully this assignment.

IN WITNESS WHEREOF, I hereto set my hand and seal at	····
IN WITNESS WHEREOF, I hereto set my hand and seal at	
1 Enord allen	L.S
Ronald A. Weimer	
STATE OF:	
COUNTY OF Max :: ss.	٠
Before me this 14th day of April , 1994, personally appeared	ment
Ronald A. Weimer, known to me to be the person whose name is subscribed to the foregoing Assign	ad
and acknowledged that he executed the same as his free act and deed for the purposes therein contained	eu.
Lish Loman-Dailer	
Notary Public	

My Commission Expires: 3-36-03

IN WITNESS WHEREOF, I hereto my hand and seal at Boise, Ia.
\mathcal{I}
this <u>15th</u> day of April, (1998)
(ant) () (B)
Scott J. DeBoer
STATE OF IDAHO:
iss.
COUNTY OF <u>AOA</u> :
Before me this
Scott I DeBoer, known to me to be the person whose name is subscribed to the foregoing Assignment, and
acknowledged that he executed the same as his free act and deed for the purposes therein contained.
Xusana Besone
Notary Public
My Commission Expires: 3/12/2002
[Notaty's Seat Here] *
W AUBLIC .
ELLO ATE OF IDAHOLINIA
Towns Worth Wo
IN WITNESS WHEREOF, I hereto set my hand and seal at Boise, Johnson
this 15th day of April , 1998
Lan York L.S.
Dan Gealy STATE OF TOBBO
STATE OF TOPHO::ss.
COUNTY OF ADA :
Before me this day of, 1999, personally appeared
Dan Gealy, known to me to be the person whose name is subscribed to the foregoing Assignment, and
acknowledged that he executed the same as his free ast and deed for the purposes therein contained.
(Wusunux Rhesome)
Notary Public
My Commission Expires: 8/12/2002
My Commission Expires: 5/12/0000
[Notary's Seal Head]
OF IDA TURE
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ASSIGNMENT

For valuable consideration, I, Husam N. Al-Shareef of Muraijeb, Al-Ain, United Arab Emirates, hereby assign to Micron Technology, Inc., a Delaware corporation having a place of business at 8000 S. Federal Way, Boise, Idaho 83706-9632, and its successors and assigns (collectively hereinafter called "the Assignee"), the entire right, title and interest throughout the world in the inventions and improvements which are subject of an application for United States Patent signed by me, entitled

FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET RAPID THERMAL OXIDATION PROCESS

AN INSULATING PIEM COING IT WELL TO THE TELESCOPE
filed on April 22, 1999 and assigned U.S. Serial Number 09/296, 835, and we authorize and request the attorneys appointed in said application to hereafter complete this assignment by inserting above the filing date and serial number of said application when known; this assignment including said application, any and all United States and foreign patents, utility models, and design registrations granted for any of said inventions or improvements, and the right to claim priority based on the filing date of said application under the International Convention for the Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all other treaties of like purposes; and we authorize the Assignee to apply in all countries in my name or in its own name for patents, utility models, and design registrations and like rights of exclusion and for inventors' certificates for said inventions and improvements; and I agree for myself and my heirs, legal representatives and assigns, without further compensation to perform such lawful acts and to sign such further applications, assignments, Preliminary Statements and other lawful documents as the Assignee may reasonably request to effectuate fully this assignment. IN WITNESS WHEREOF, I hereto set my hand and seal at Al-Ain United Arab Sautabas. LLS
TUSAM APRILLED
Husam N. Al-Shareef
Witness: $\boxed{\frac{1}{2}}$ Date: $\boxed{\frac{5-17-99}{2}}$



COMBINED DECLARATION AND POWER OF ATTORNEY

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name,

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled <u>FABRICATION OF DRAM AND OTHER SEMICONDUCTOR</u> DEVICES WITH AN INSULATING FILM USING A WET RAPID THERMAL OXIDATION PROCESS, the
specification of which
is attached hereto.
was filed on as Application Serial No
and was amended on was described and claimed in PCT International Application No
filed on and as amended under PCT Article 19 on
fried on and as amended under 1 of fried 15 on
I hereby state that I have reviewed and understand the contents of the above-identified specification, including the claims, as amended by any amendment referred to above.
I acknowledge the duty to disclose all information I know to be material to patentability in accordance with Title 37, Code of Federal Regulations, §1.56.
I hereby appoint the following attorneys and/or agents to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith: Michael L. Lynch, Reg. No. 30,871; Lia M. Pappas, Reg. No. 34,095; W. Eric Webostad, Reg. No. 35,406; Charles B. Brantley II, Reg. No. 38,086; Samuel Borodach, Reg. No. 38,388; Victor Siber, Reg. No. 27149; Stephan J. Filipek, Reg. No. 33,384; John B. Pegram, Reg. No. 25,198; William J. Hone, Reg. No. 26,739; Frederick H. Rabin, Reg. No. 24,488; Richard P. Ferrara, Reg. No. 30,632; Gabriel P. Kralik, Reg. No. 34,855; Andrew T. D'Amico, Reg. No. 33,375; Andrew N. Parfomak, Reg. No. 32,431.
Address all telephone calls to Samuel Borodach at telephone number 212/765-5070.
Address all correspondence to Victor Siber, Fish & Richardson P.C., 45 Rockefeller Plaza, New York, NY 10111.
I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patents issued thereon.
Full Name of Inventor: Ronald A. Weimer
Inventor's Signature: Parit a Ven Date: 17 apr. 1 1999
Residence Address: 1696 E. Victory Road. Boise, Idaho 83706
Citizen of: U.S.A.
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COMBINED DL RATION AND POWER OF AT 1 SEY CONTINUED ____ Date: 4/15/99 Full Name of Inventor: Scott I. DeBoen Inventor's Signature: Residence Address: 259 E. Twin Willow, Boise, Idaho 83706 Post Office Address: 259 E. Twin Willow, Boise, Idaho 83706 Citizen of: U.S.A. ___ Date: 4/15/55 Full Name of Inventor: Dan Gealy Inventor's Signature: Residence Address: 4300 Junayo Ln, Kuna, Idaho 83634 Post Office Address: 4300 Junayo Ln. Kuna, Idaho 83634 Citizen of: U.S.A. Full Name of Inventor: Husam N. Al-Shareef The first than the first that the fi Date: -Residence Address: 2856 W. Cherry Lane, Boise, Idaho 83704 Inventor's Signature: ___ Post Office Address: 2856 W. Cherry Lane, Boise, Idaho 83704 Citizen of: U.S.A. Han Han

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Full Name of Inventor: Husam N. Al-Shareef	
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